

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 279585US0X PCT		SERIAL NO. 10/554,218	
LIST OF REFERENCES CITED BY APPLICANT		APPLICANT					
		Katsuya OKUMURA, et al.		FILING DATE		GROUP	
		October 24, 2005		1634			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA	US 2001/0019029 A1	9/6/2001	Yu-Chong TAI, et al.			
	AB	5,753,014	5/19/1998	Cornelis Johannes Maria Van RIJN			
	AC						
	AD						
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	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
	AO	EP 1 471 991 B1	6/21/2006	Europe	YES	NO	
	AP						
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW	Xing YANG et al. "Micromachined membrane particle filters" Sensors and Actuators 73 (1999) pages 184-191.					
	AX	Cees van RIJN et al. "Deflection and Maximum Load of Microfiltration Membrane Sieves Made with Silicon Micromachining" Journal of Microelectromechanical Systems VOL. 6 NO. 1. March 1997, pages 48-54					
	AY						
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner					Date Considered		
<p>*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							